



PRODUCT/PROCESS CHANGE NOTIFICATION

PCN APG-BAD/12/7432
Dated 10 Sep 2012

**VIPOWER M03 / M03.5 in SOT-223: Assembly Transfer from
Carsem to Fujitsu Subcontractor**

Table 1. Change Implementation Schedule

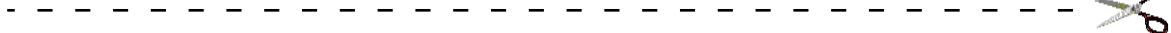
| | |
|--|-------------|
| Forecasted implementation date for change | 30-Nov-2012 |
| Forecasted availability date of samples for customer | 03-Sep-2012 |
| Forecasted date for STMicroelectronics change Qualification Plan results availability | 03-Sep-2012 |
| Estimated date of changed product first shipment | 10-Dec-2012 |

Table 2. Change Identification

| | |
|---|---|
| Product Identification (Product Family/Commercial Product) | see enclosed list |
| Type of change | Package assembly location change |
| Reason for change | Logistic |
| Description of the change | Please be informed that VIPower M03 / M03.5 products housed in SOT-223 will be transferred from assembly Carsem to Fujitsu Subcontractor. Due to all the products will be transferred in lead-free configuration only, products in lead-present configuration will be converted as well according to PCN APG-AED/10/5437 dated April 1, 2010 (Passive Pad Implementation) already communicated. See enclosed reference table of new part numbers. |
| Change Product Identification | Letter code "G" on plant code traceability |
| Manufacturing Location(s) | 1]Sc Carsem M - Malaysia |

Table 3. List of Attachments

| | |
|----------------------------|--|
| Customer Part numbers list | |
| Qualification Plan results | |



| | | |
|--|--|---------------------|
| Customer Acknowledgement of Receipt | | PCN APG-BAD/12/7432 |
| Please sign and return to STMicroelectronics Sales Office | | Dated 10 Sep 2012 |
| <input type="checkbox"/> Qualification Plan Denied <input type="checkbox"/> Qualification Plan Approved <input type="checkbox"/> Change Denied <input type="checkbox"/> Change Approved | Name: Title: Company: Date: Signature: | |
| Remark | | |

DOCUMENT APPROVAL

| Name | Function |
|--------------------|-------------------|
| Liporace, Nicola | Marketing Manager |
| Nicoloso, Riccardo | Product Manager |
| Minerva, Francesco | Q.A. Manager |



Product Change Notification

VIpower M03/M03.5 in SOT-223: Transfer from assembly plant Carsem to Assembly plant Fujitsu.

INVOLVED P&L FAMILY: 30

WHAT:

Assembly of VIpower M03/M03.5 products housed in SOT-223 will be transferred from subcontractor Carsem (Malaysia) to Fujitsu (China).

WHY:

Logistic.

WHO:

All the Customers using below list of products.

Due to all the products will be transferred in lead-free configuration only, products in lead-present configuration will be converted as well according to PCN APG-AED/10/5437 (Passive pad implementation) dated April 1, 2010 already communicated.

Below the reference new part numbers.

| CARSEM | | | FUJITSU | | |
|--------------|---------------------|----|--------------|-----------------|---|
| Silicon Line | Current Part Number | | Silicon Line | New Part Number | Notes |
| VN73* | 09399028-E | -> | VNL6 | VNN1NV04PTR-E | Passive pad silicon versions according to PCN 5437 issued in April 2010 |
| VN73* | 9399028 | -> | VNL6 | VNN1NV04PTR-E | |
| VN73* | VNN1NV0413TR | -> | VNL6 | VNN1NV04PTR-E | |
| VN79* | 28006923 | -> | VNS2 | VNN7NV04PTR-E | |
| VN79* | VNN7NV0413TR | -> | VNS2 | VNN7NV04PTR-E | |
| VN84* | VNN3NV0413TR | -> | VNS6 | VNN3NV04PTR-E | |
| VNL6 | VNN1NV04PTR-E | -> | VNL6 | VNN1NV04PTR-E | |
| VNS2 | VNN7NV04PTR-E | -> | VNS2 | VNN7NV04PTR-E | |
| VNS6 | VNN3NV04PTR-E | -> | VNS6 | VNN3NV04PTR-E | |

*No Passive Pad Silicon Version

WHEN:

Tentative date of change is: December 2012

Qualification report included to this PCN (RR002612CT2235).

WHERE:

Carsem (Malaysia) sending plant – Fujitsu (China) receiving plant.

| |
|---|
| <p>SOT223 assembly process qualification in NANTONG FUJITSU subcontractor</p> |
|---|

| General Informations | |
|-----------------------------------|--------------------|
| Commercial Product | VNN7NV04P-E |
| Product Line | VNS2 |
| Silicon process technology | VIpower M0_3.5 |
| Package | SOT223 |

| Locations | |
|---------------------------------|--------------------------------|
| Diffusion fab location | ST AMK6 Ang Mo Kio (Singapore) |
| Assembly plant location | Subcon Nantong Fujitsu (China) |
| Test plant location | ST Shenzhen (China) |
| Reliability lab location | ST Catania (Italy) |

| General Informations | |
|-----------------------------------|--------------------|
| Commercial Product | VNN3NV04P-E |
| Product Line | VNS6 |
| Silicon process technology | VIpower M0_3.5 |
| Package | SOT223 |

| Locations | |
|---------------------------------|--------------------------------|
| Diffusion fab location | ST CT6 Catania (Italy) |
| Assembly plant location | Subcon Nantong Fujitsu (China) |
| Test plant location | ST Shenzhen (China) |
| Reliability lab location | ST Catania (Italy) |

| General Informations | |
|-----------------------------------|--------------------|
| Commercial Product | VNN1NV04P-E |
| Product Line | VNL6 |
| Silicon process technology | VIpower M0_3.5 |
| Package | SOT223 |

| Locations | |
|---------------------------------|--------------------------------|
| Diffusion fab location | ST CT6 Catania (Italy) |
| Assembly plant location | Subcon Nantong Fujitsu (China) |
| Test plant location | ST Shenzhen (China) |
| Reliability lab location | ST Catania (Italy) |

Author:
F. CERAULO
Product Qualification Eng
APG Q&R Catania

Reliability and electrical test executed by:
G. Foti
Rel. Eng.
IMS Rel Dept. – APG Support

| Table of contents | | |
|--------------------------|------------|--|
| Section | Pag | Content |
| 1 | 3 | Reliability evaluations overview |
| 1.1 | 3 | Objectives |
| 1.2 | 3 | Results |
| 2 | 4 | Traceability |
| 3 | 6 | VNN7NV04P-E - Devices characteristics |
| 3.1 | 6 | Generalities |
| 3.2 | 7 | Pins connection |
| 3.3 | 7 | Blocks diagram |
| 3.4 | 7 | Bonding diagram |
| 4.0 | 8 | VNN3NV04P-E - Devices characteristics |
| 4.1 | 8 | Generalities |
| 4.2 | 9 | Pins connection |
| 4.3 | 9 | Blocks diagram |
| 4.4 | 9 | Bonding diagram |
| 5.0 | 10 | VNN1NV04P-E - Devices characteristics |
| 5.1 | 10 | Generalities |
| 5.2 | 11 | Pins connection |
| 5.3 | 11 | Blocks diagram |
| 5.4 | 11 | Bonding diagram |
| 5.5 | 12 | Package outline / Mechanical data |
| 6 | 13 | Reliability qualification plan and results – Summary table |

- 1. Reliability evaluations overview

1.1 Objectives

Aim of this report is to present the results of the reliability evaluations performed to qualify the subcontractor NANTONG FUJITSU (China) as new location to assembly in package **SOT223** the VIPower products designed in M0_3.5 technology.

The products chosen as test vehicles are: **VNN7NV04P-E** (VNS2 as ST internal code) and the **VNN1NV04P-E** (VNL6 as ST internal code) diffused in ST AMK6 Ang Mo Kio (Singapore), the **VNN3NV04P-E** (VNS6 as ST internal code) diffused in ST CT6 Catania (Italy).

The qualification was based on 3 lots, one lot per vehicle, according to the **AEC_Q100 Rev.G** specification the following tests were performed: Preconditioning (PC), Temperature Humidity Bias (THB), Autoclave (AC), Thermal Cycling (TC), Power Temperature Cycling (PTC), High Temperature Storage (HTS) as Accelerated Environment Stress (test Group A); High Temperature Operative Life (HTOL) as Accelerated Lifetime Simulation (test Group B); Wire Bond Pull/Shear tests (WBP, WBS), Solderability (SD), Physical Dimension (PD) as Package Assembly Integrity (test Group C); Gate Leakage (GL) as Electrical Verification (test Group E).

1.2 Results

All reliability tests have been completed with positive results, neither functional nor parametric rejects were detected at final electrical testing.

Based on the overall positive results we consider the products qualified from a reliability point of view.

- 2. Traceability

VNN7NV04P-E (VNS2)

| Wafer fab information | |
|----------------------------------|--------------------------------|
| Wafer fab manufacturing location | ST AMK6 Ang Mo Kio (Singapore) |
| Wafer diameter (inches) | 6 |
| Silicon process technology | VIPower M0_3.5 |
| Die finishing back side | Ti-Ni-Au |
| Die size (micron) | 2540 x 2130 |
| Metal levels / materials | 1 level / AISi (3.2 µm) |
| Die finishing front side | SiN/POLYIMIDE |
| Diffusion Lots # | 6110J4T |

| Assembly Information | |
|-----------------------------------|---|
| Assembly plant location | SC - NANTONG FUJITSU (China) |
| Package description | SOT-223 |
| Molding compound | SUMITOMO EMEG600F |
| Wires bonding materials/diameters | Au 2.0mils |
| Die attach material | SOFT SOLDER DIE ATTACH 95.5Pb/2Sn/2.5Ag |
| Assembly Lots # | Lot1: GK22012101 |

| Final Testing Information | |
|---|---------------------|
| Electrical testing manufacturing location | ST Shenzhen (China) |

VNN3NV04P-E (VNS6)

| Wafer fab information | |
|----------------------------------|-------------------------|
| Wafer fab manufacturing location | ST CT6 Catania (Italy) |
| Wafer diameter (inches) | 6 |
| Silicon process technology | VIPower M0_3.5 |
| Die finishing back side | Ti-Ni-Au |
| Die size (micron) | 2540 x 2130 |
| Metal levels / materials | 1 level / AISi (3.2 µm) |
| Die finishing front side | SiN/POLYIMIDE |
| Diffusion Lots # | 3204134 |

| Assembly Information | |
|-----------------------------------|---|
| Assembly plant location | SC - NANTONG FUJITSU (China) |
| Package description | SOT-223 |
| Molding compound | SUMITOMO EMEG600F |
| Wires bonding materials/diameters | Au 2.0mils |
| Die attach material | SOFT SOLDER DIE ATTACH 95.5Pb/2Sn/2.5Ag |
| Assembly Lots # | Lot1: GK21917V01 |

| Final Testing Information | |
|---|---------------------|
| Electrical testing manufacturing location | ST Shenzhen (China) |

VNN1NV04P-E (VNL6)

| Wafer fab information | |
|---|--------------------------------|
| Wafer fab manufacturing location | ST AMK6 Ang Mo Kio (Singapore) |
| Wafer diameter (inches) | 6 |
| Silicon process technology | VIpower M0_3.5 |
| Die finishing back side | Ti-Ni-Au |
| Die size (micron) | 1710 x 1520 |
| Metal levels / materials | 1 level / AISi (3.2 μm) |
| Die finishing front side | SiN/POLYIMIDE |
| Diffusion Lots # | 6811LPK |

| Assembly Information | |
|--|---|
| Assembly plant location | SC - NANTONG FUJITSU (China) |
| Package description | SOT-223 |
| Molding compound | SUMITOMO EMEG600F |
| Wires bonding materials/diameters | Au 2.0mils |
| Die attach material | SOFT SOLDER DIE ATTACH 95.5Pb/2Sn/2.5Ag |
| Assembly Lots # | Lot1: GK8381VX01 |

| Final Testing Information | |
|--|---------------------|
| Electrical testing manufacturing location | ST Shenzhen (China) |

- 3. VNN7NV04P-E - Devices characteristics

3.1 Generalities



VNN7NV04P-E, VNS7NV04P-E

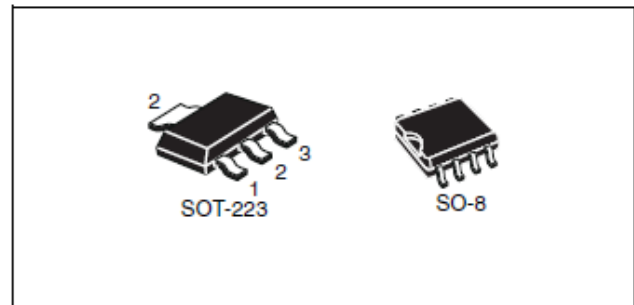
OMNIFET II

fully autoprotected Power MOSFET

Features

| Type | $R_{DS(on)}$ | I_{lim} | V_{clamp} |
|----------------------------|---------------|-----------|-------------|
| VNN7NV04P-E VNS7NV04P-E | 60 m Ω | 6 A | 40 V |

- Linear current limitation
- Thermal shutdown
- Short circuit protection
- Integrated clamp
- Low current drawn from input pin
- Diagnostic feedback through input pin
- ESD protection
- Direct access to the gate of the Power MOSFET (analog driving)
- Compatible with standard Power MOSFET in compliance with the 2002/95/EC European Directive

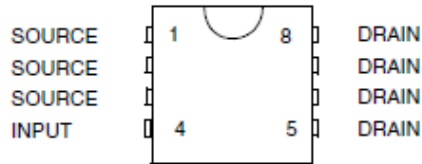


Description

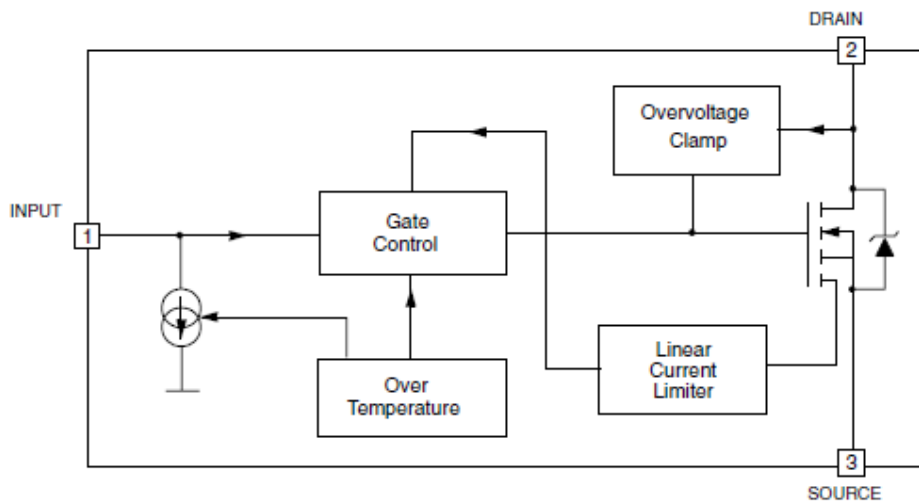
The VNN7NV04P-E, VNS7NV04P-E, are monolithic devices designed in STMicroelectronics VIPower™ M0-3 Technology, intended for replacement of standard Power MOSFETs from DC up to 50 kHz applications. Built in thermal shutdown, linear current limitation and overvoltage clamp protect the chip in harsh environments.

Fault feedback can be detected by monitoring the voltage at the input pin.

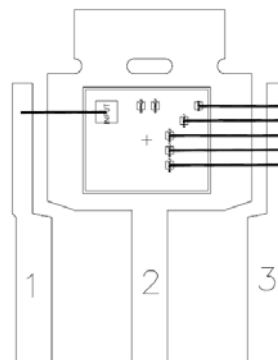
3.2 Pins connection



3.3 Blocks diagram



3.4 Bonding diagram



- 4. VNN3NV04P-E - Devices characteristics

4.1 Generalities



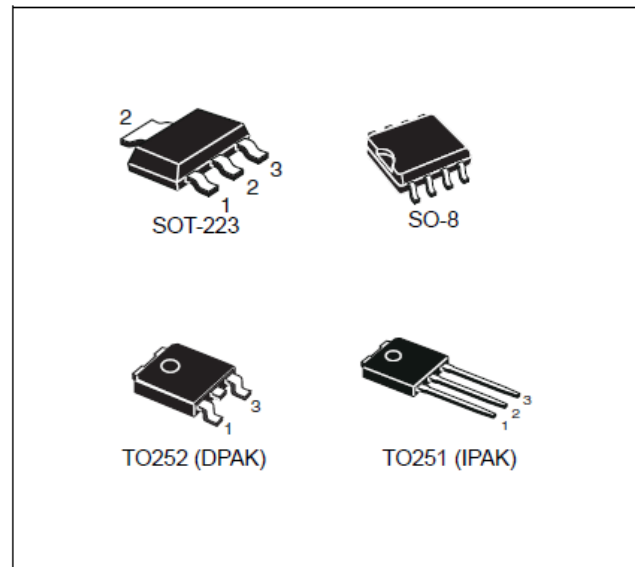
VNN3NV04, VNS3NV04 VND3NV04, VND3NV04-1

OMNIFET II
fully autoprotected Power MOSFET

Features

| Type | $R_{DS(on)}$ | I_{lim} | V_{clamp} |
|--|--------------|-----------|-------------|
| VNN3NV04 VNS3NV04 VND3NV04 VND3NV04-1 | 120 mΩ | 3.5 A | 40 V |

- Linear current limitation
- Thermal shutdown
- Short circuit protection
- Integrated clamp
- Low current drawn from input pin
- Diagnostic feedback through input pin
- ESD protection
- Direct access to the gate of the Power MOSFET (analog driving)
- Compatible with standard Power MOSFET in compliance with the 2002/95/EC European Directive

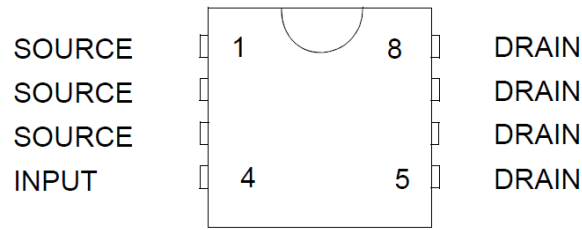


Description

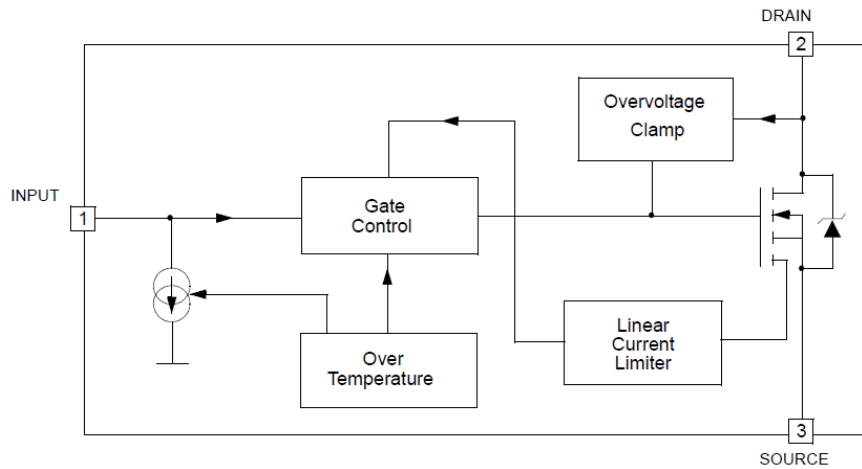
The VNN3NV04, VNS3NV04, VND3NV04, VND3NV04-1, are monolithic devices designed in STMicroelectronics™ VIPower™ M0-3 Technology, intended for replacement of standard Power MOSFETs from DC up to 50 kHz applications. Built in thermal shutdown, linear current limitation and overvoltage clamp protect the chip in harsh environments.

Fault feedback can be detected by monitoring the voltage at the input pin.

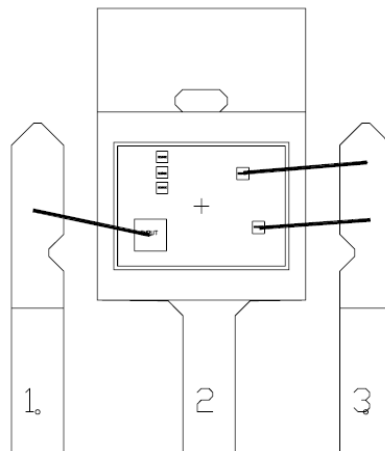
4.2 Pins connection



4.3 Blocks diagram



4.4 Bonding diagram



- 5. VNN1NV04P-E - Devices characteristics

5.1 Generalities



VNN1NV04P-E, VNS1NV04P-E

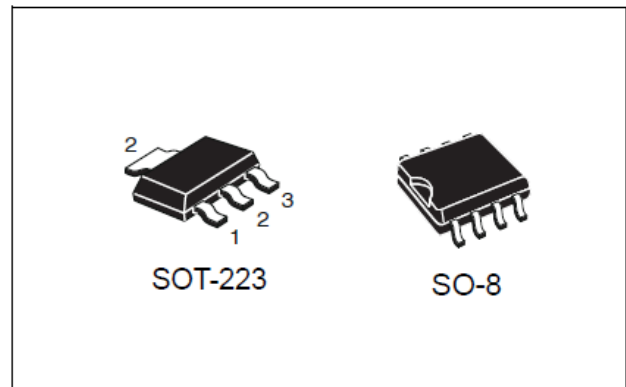
OMNIFET II

fully autoprotected Power MOSFET

Features

| Parameter | Symbol | Value |
|-----------------------------------|-------------|----------------|
| Max on-state resistance (per ch.) | R_{ON} | 250 m Ω |
| Current limitation (typ) | I_{LIMH} | 1.7 A |
| Drain-source clamp voltage | V_{CLAMP} | 40 V |

- Linear current limitation
- Thermal shutdown
- Short circuit protection
- Integrated clamp
- Low current drawn from input pin
- Diagnostic feedback through input pin
- ESD protection
- Direct access to the gate of the Power MOSFET (analog driving)
- Compatible with standard Power MOSFET

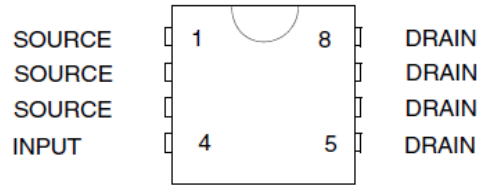


Description

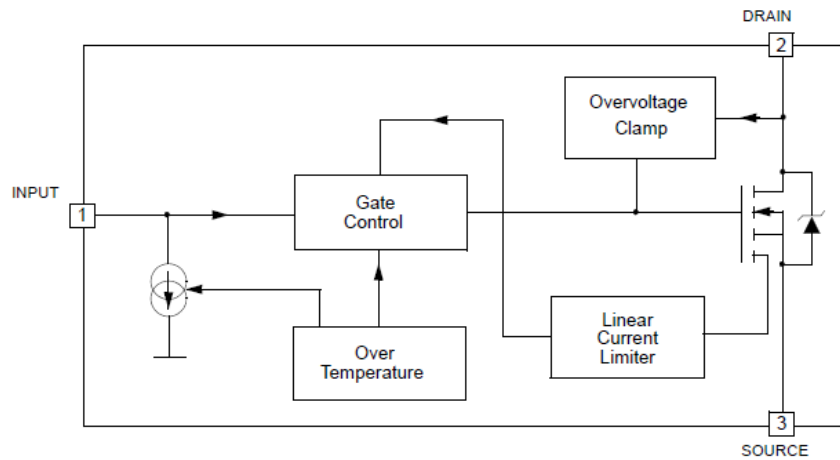
The VNN1NV04P-E, VNS1NV04P-E are monolithic devices designed in STMicroelectronics VIPower M0-3 Technology, intended for replacement of standard Power MOSFETs from DC up to 50 kHz applications. Built in thermal shutdown, linear current limitation and overvoltage clamp protect the chip in harsh environments.

Fault feedback can be detected by monitoring the voltage at the input pin.

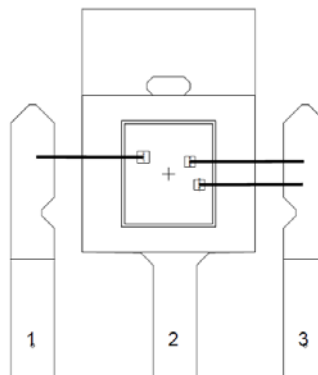
5.2 Pins connection



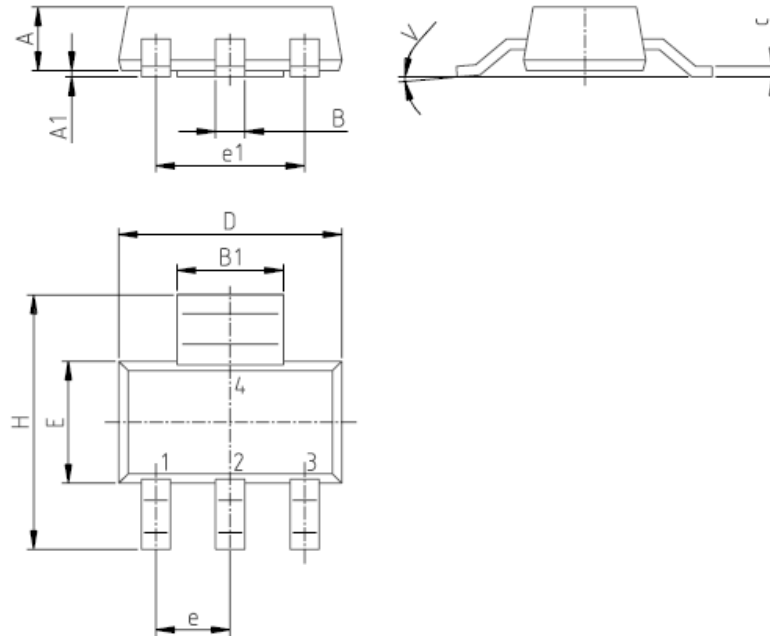
5.3 Blocks diagram



5.4 Bonding diagram



5.5 Package outline/Mechanical data



| Dim. | mm. | | | inch | | |
|------|-----------|------|------|--------|-------|-------|
| | Min. | Typ. | Max. | Min. | Typ. | Max. |
| A | | | 1.8 | | | 0.071 |
| B | 0.6 | 0.7 | 0.85 | 0.024 | 0.027 | 0.033 |
| B1 | 2.9 | 3 | 3.15 | 0.114 | 0.118 | 0.124 |
| c | 0.24 | 0.26 | 0.35 | 0.009 | 0.01 | 0.014 |
| D | 6.3 | 6.5 | 6.7 | 0.248 | 0.256 | 0.264 |
| e | | 2.3 | | | 0.09 | |
| e1 | | 4.6 | | | 0.181 | |
| E | 3.3 | 3.5 | 3.7 | 0.13 | 0.138 | 0.146 |
| H | 6.7 | 7 | 7.3 | 0.264 | 0.276 | 0.287 |
| V | 10° (max) | | | | | |
| A1 | 0.02 | | 0.1 | 0.0008 | | 0.004 |

- 6. Reliability qualification plan and results

| AEC # | Test Name | STM Test Conditions | Sample Size/Lots | Results Fails/SS/Lots | Comments |
|-------|---------------------------------|---|---|-----------------------|----------|
| A1 | PC Pre Cond | - Preconditioning according to level 3 Jedec JESD22-A113F - Reflow according to Jedec JSTD020D-1 | Before THB, AC, TC, PTC, HTOL. Reliability executed on units soldered on PCB | | |
| A2 | THB Temp Humidity Bias | Ta=85°C, RH=85%, Vcc=24V for 1000 hours | 77/3 | 0/77/3 | |
| A3 | AC Autoclave | Ta=121°C, Pa=2atm, RH=100% for 96 hours | 77/3 | 0/77/3 | |
| A4 | TC Temp. Cycling | Ta=-65°C / +150°C for 500 cycles | 77/3 | 0/77/3 | |
| A5 | PTC Power Temp. Cycling | Per JA105. Ta=-40°C / +125°C for 1000 cycles. Test before and after at room and hot temperatures. | 45/1 | 0/45/1 | |
| A6 | HTSL High Temp. Storage Life | Ta=150°C for 1000 hours. TST before and after at room and hot temperatures. | 45/3 | 0/45/3 | |
| B1 | HTOL High Temp. Op. Life | Bias Static stress (JESD22-A108): Ta= 150°C , Vcc=32V for 1000 hours | 77/3 | 0/77/3 | |
| C1 | WBS Wire Bond Shear | Per AEC-Q100-001. See Appendix 3 procedure. 0 and Ppk >= 1.66 or Cpk >= 1.33 | 30 bonds from minimum 5 of units | Passed | |
| C2 | WBP Wire Bond Pull | Per MIL-STD883, M2011 Condition C or D. 0 and Ppk >= 1.66 or Cpk >= 1.33 | 30 bonds from minimum 5 of units | Passed | |
| C3 | SD Solderability | | 15/1 | Passed | |
| C4 | PD Physical Dimensions | | 10/3 | Passed | |
| E8 | GL Gate Leakage | | 6/1 | Passed | |

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